

**IN THE ABSTRACT:**

Please enter this application with the Abstract as it appears in the enclosed English language re-translation of the original and published Abstract, and is attached to the English translation of the specification. Similar to the above request concerning the title, the translation of the Abstract as shown in PCT Publication No. WO/2004/062933 was done at the IB, and our Japanese associate and translator has indicated that this Abstract is not accurate.

The Abstract as it appears in the enclosed English language translation is the more accurate and faithful translation of the original Abstract as it was filed in the PCT International application, and it is therefore requested that the Abstract be changed to this Abstract that more accurately identifies this invention, and as it has been faithfully re-translated by our Japanese associate and translator.

## Abstract

In a stencil material conveyor system for conveying stencil material unrolled from a stencil material roll, the stretch or the shrinkage of the image on the conveyed stencil material is avoided.

- 5 The residue of stencil material roll in a stencil material roll (21b) is calculated by a residue calculating means (65), by cumulatively subtracting a length of the stencil made from the total length of the stencil material roll stored in a storage means (70) of the stencil material roll (21b). The write pulse motor is rotated at a higher  
10 speed as the residue is reduced, thereby controlling the rotational speed of the platen roller (23) to compensate for reduction of the conveying distance due to slip of the platen roller (23) by the back tension applied to the stencil material and to convey the stencil material at a constant conveying speed.

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